

# ENVIRONMENTAL MAPPING AND CLASSIFICATION SYSTEM

## ENVIRONMENTAL MAPPING AND CLASSIFICATION

### PROPRIETARY AND CONFIDENTIAL

NaviFloor Robotics, Inc.

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### 1. OVERVIEW AND SCOPE

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1. This document describes the proprietary Environmental Mapping and Classification System.

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2. The EMCS comprises the integrated hardware and software systems, methods

## **2. DEFINITIONS**

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1. "Environmental Data" means all spatial, topographical, surface characteristics

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2. "Classification Parameters" means the defined set of environmental attributes

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3. "Navigation Mesh" means the three-dimensional representation of traversable

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4. "Surface Profile" means the detailed characterization of floor surfaces including

### **3. SYSTEM ARCHITECTURE**

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#### **1. Sensor Integration Layer**

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Multi-beam LiDAR arrays (Model NF-L420X)

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Depth-sensing cameras (Resolution: 1920x1080, 60fps)

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Surface texture analysis sensors

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Inertial measurement units (IMU)

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#### **2. Data Processing Layer**

- - 3 -

Real-time point cloud generation

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Surface classification algorithms

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Dynamic obstacle detection

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Environmental change tracking

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3. Classification Engine

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Machine learning-based surface identification

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Terrain complexity scoring

- - 4 -

Navigation risk assessment

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Dynamic route optimization

## **4. MAPPING METHODOLOGY**

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### **1. Initial Mapping Process**

The System employs a multi-pass mapping approach:

- a) Primary scan for structural elements
- b) Secondary scan for surface characteristics
- c) Verification scan for data validation

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## 2. Classification Categories

Environment elements are classified into:

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Static structural elements

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Semi-permanent fixtures

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Dynamic obstacles

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Restricted zones

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Preferred navigation paths

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## 3. Update Protocols

- - 6 -

Continuous background mapping during normal operation

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Scheduled comprehensive remapping

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Event-triggered partial remapping

## **5. PROPRIETARY ALGORITHMS**

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1. Surface Analysis Algorithm (Patent Pending, App. No. 16/234,567)

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Multi-layer surface characterization

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Friction coefficient calculation

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Load-bearing capacity assessment

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Wear pattern recognition

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2. Dynamic Navigation Mesh Generation

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Real-time mesh updates

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Predictive path planning

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Collision avoidance optimization

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Multi-robot coordination



## **6. DATA MANAGEMENT AND SECURITY**

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### **1. Storage Requirements**

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Local edge processing units

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Encrypted cloud backup

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Version control system

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Delta update management

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### **2. Access Controls**

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Role-based access system

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Audit logging

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Change tracking

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Data retention policies

## **7. INTEGRATION SPECIFICATIONS**

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1. Hardware Requirements

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Minimum sensor configuration

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Processing unit specifications

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Network infrastructure requirements

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Power supply specifications

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2. Software Integration

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API documentation

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Communication protocols

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Data format specifications

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Error handling procedures

## **8. INTELLECTUAL PROPERTY PROTECTION**

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1. All components of the EMCS, including but not limited to algorithms, me

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2. Any improvements, modifications, or derivatives of the EMCS developed

## **9. COMPLIANCE AND CERTIFICATION**

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1. The EMCS has been certified to meet:

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ISO/TS 15066:2016 (Robots and robotic devices)

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IEC 61508 (Functional Safety)

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CE marking requirements

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ANSI/RIA R15.06-2012

## **10. DISCLAIMER AND LIMITATION OF LIABILITY**

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1. The EMCS is provided "as is" without warranty of any kind, either express

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2. NaviFloor Robotics, Inc. shall not be liable for any direct, indirect, incidental

## **AUTHENTICATION**

This document is maintained under version control and is considered valid only when signed and sealed in its electronic form with digital signature verification.

Approved by:

Dr. Elena Kovacs

Chief Research Officer

NaviFloor Robotics, Inc.

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